RECEIVED CENTRAL FAX CENTER

Ø001/039

FEB 2 6 2007

Docket No.: 020732-97.668 (7493)

Appl. No. 10/792,038

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of: Docket No.: 020732-97.668 (7493)Applicants: RATH, Melissa K., et al. 4823 Conf. No.: Application No.: 10/792,038 Art Unit: 1752 Date Filed: March 3, 2004 Examiner: LE, Hoa Van Title: COMPOSITION AND PROCESS FOR Customer No.: 24239 POST-ETCH REMOVAL OF PHOTORESIST AND/OR SACRIFICIAL ANTI-REFLECTIVE MATERIAL DEPOSITED ON A SUBSTRATE

FACSIMILE TRANSMISSION CERTIFICATE Attn: Examiner Hoa Van Le

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on February 26, 2006, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

 39	
Number of Pages (including cover)	
 Lillian Glenn	
Limai Geni	
 February 26, 2006	
Date	

RESPONSE TO NOVEMBER 24, 2006 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/792,038

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

Docket No.: 020732-97.668 (7493)

Appl. No. 10/792,038

Please amend the claims, as set out in the following Section I (the Claims).

Remarks addressing the substance of the November 24, 2006 Office Action are set out in the Section II (Remarks) hereof.